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Docket No.: GWS/18240C2/Mathys

**PATENT APPLICATION**  
**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents, P. O. Box 1450; Alexandria, VA 22313-1450, on:

November 10, 2003

(date)

*Lori G. Witkin*  
Lori G. Witkin

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In re: Application of: Xu SHI, et al.

Serial No. : 10/014,387

Group Art Unit: 1745

Filed : December 11, 2001

Examiner: G. Cantelmo

For : FILTERED CATHODE ARC SOURCE  
DEPOSITION APPARATUS

New York, New York  
November 10, 2003

**AMENDMENT**

Commissioner for Patents  
P. O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Official Action dated July 14, 2003, please amend this patent application as follows:

Amendments to the Specification begin on page 2 of this Response.

Amendments to the Claims are reflected in the Complete Listing of the Claims and begin on page 3 of this Response.

Remarks begin on page 8 of this Response.